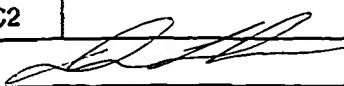
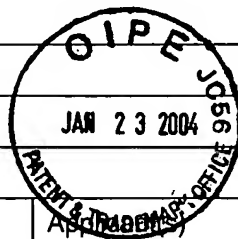


U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)					Docket No. AMAT/4100.Y2/CMP/ CMP/RKK		Serial No. 10/033,732	
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant Chen, et al.		Confirmation No. 7456	
(Use several sheets if necessary)					Filing Date December 27, 2001		Group 3723	
Examiner David B. Thomas								
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*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
DBT	B1	01/52307	07/19/2001	WO	H01L		<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B2	01/13416	02/22/2001	WO	H01L	21/288	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B3	01/63018	08/30/2001	WO	C25D	17/00	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B4	01/71066	09/27/2001	WO	C25D	7/12	<input type="checkbox"/>	<input checked="" type="checkbox"/>
DBT	B5	01/88954	11/22/2001	WO	H01L		<input type="checkbox"/>	<input checked="" type="checkbox"/>
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Chen, et al.	Confirmation No. 7456
(Use several sheets if necessary)		Filing Date December 27, 2001	Group 3723
Examiner	David B. Thomas		



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